IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Mineo HIRAMATSU, et al.

Serial No.:

10/569,838

Group Art Unit:

Unknown

Filed:

February 24, 2006

Examiner:

Unknown

For:

METHOD FOR PRODUCING CARBON NANOWALLS,

CARBON NANOWALL, AND APPARATUS FOR PRODUCING

**CARBON NANOWALLS** 

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to Applicant duty of disclosure under 37 CFR §1.56, Applicant respectfully brings the following documents cited in the Japanese Office Action in a counterpart foreign application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which Applicant is aware.

In compliance with the concise explanation requirement under 37 CFR §1.98(a)(3) for foreign language documents, Applicant encloses herewith a copy of the Japanese Office Action citing such documents, together with an English-language version (if not already included) of that portion of the Office Actions indicating the degree of relevance found by the foreign office. Further, English-language abstracts are attached to the references.

The enclosed documents are (1) Office Action of Japanese patent application No. 2005-513488 issued on September 26, 2006, (2) its partial translation, (3) its cited reference Nos. 11-067490, 2003-173980, and 2001-81570 (4) and an article by Takashi Hirao, et al.

Serial No.: 10/569,838 Docket No. F06-436-US

FUJIT.081

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Date: 12 27 0

MCGINN INTELLECTUAL PROPERTY

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Respectfully submitted,

Sean M. McGinn, Esq. Registration No. 34,386

	INFORMATION DISCLOSURE CITATION (S)				Docket Number (Optional) F06-436-US		Application Number 10/569,838		
	INFQ	RMATION DISCLOSURE (Use several sheets if necessor)	CITATION	12	Applicant(s) Mineo HIRAMAT	SU, et al.			
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	REF	DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	YES	NO NO
		2001-081570	03/27/2001	JAPAN				185	
	11-067490 2003-173980		03/09/1999	JAPAN	<b>N</b>			ABS	
			06/20/2003	JAPAN	1			ABS	
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				DOCUME		Author, Title, Date, 1		itc.)	
		Office Action of Japan	ese Patent Applic	ation No.	2005-513488, with par	rtial English trans	slation		
		"Formation of Vertica et al.	lly Aligned Carbo	on Nanotu	bes by Dual-RF-Plasn	na Chemical Vapo	r Disposition",	by Takashi	HIRAO,
EXAMINER					DATE CONSIDERED				
EXAMINI	ER: Init	tial if citation considered, whethe	er or not citation is i	in conforma	ance with MPEP Section	609; Draw line thre	ough citation if n	ot in conform	ance and
not consid	lered. I	nclude copy of this form with nex	ct communication to	applicant.					